

## PATENT ASSIGNMENT COVER SHEET

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<b>NATURE OF CONVEYANCE:</b>	EXECUTIVE ORDER 9424, CONFIRMATORY LICENSE
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UNIVERSITY OF ILLINOIS, CHICAGO	03/06/2019
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<b>Property Type</b>	<b>Number</b>
Application Number:	14515135
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**License to the United States Government**

**Invention Title:** Method for depositing multi element complex structures in CVD, ALD or bombined alternating mode using a single deposition system.

**Inventor(s):** Christos Takoudis, Manish Singh

**Application Serial No.:** 14/515,135

**Filing Date:** 10/15/2014

**Foreign Applications filed/intended in (countries):** None

**Grant/Contract Identification Number(s):** CMS0609377, CBET1067424

**Federal Agency:** NSF

The invention identified above is a Subject Invention under 35 U.S.C. 200, et seq., and the Standard Patent Rights clause at 37 CFR 401.14, FAR 52.227-11, or FAR 52.227-12 (if applicable) which are included among the terms of the above-identified grant or contract award from the United States Government. This document is confirmatory of:

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By Avijit Ghosh Date: 3-6-2019  
Avijit Ghosh, Comptroller

Attest: Dedra M. Williams Date: 3-7-19  
Dedra M. Williams, Secretary

For The Board of Trustees of the University of Illinois on behalf of its  
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